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PATENT  
Attorney Docket No. 04329.3299

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Tsutomu Sato et al. ) Group Art Unit: 2815  
)  
Application No.: 10/820,182 ) Examiner: Kraig, William F.  
)  
Filed: April 8, 2004 )  
)  
For: SEMICONDUCTOR DEVICE AND ) Confirmation No.: 7391  
METHOD OF MANUFACTURING )  
THE SAME )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**

Applicants petition for a two month extension of time to file a reply to the Office  
Action of November 1, 2006. A fee of \$450.00 is enclosed.

Please grant any additional extensions of time required to enter the attached  
reply and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: April 2, 2007

By: Richard V. Burgujian Reg. No. 53,232  
For Reg. No. 31,744

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